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PATENT

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Gangadjara S. Mathad

SERIAL NO:	09/874,109	)	DATE:	January 22, 2004
		)		
FILING DATE:	June 5, 2001	)	GROUP ART UNIT:	1763
		)		
TITLE:	Method of Etching	)	EXAMINER:	Allan W. Olsen
	High Aspect Ratio	)		
	Openings	)		

**TRANSMITTAL OF FORMAL DRAWINGS**

**MAIL STOP ISSUE FEE**

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**ATTN: OFFICIAL DRAFTSPERSON**

Dear Sir:

Enclosed are formal drawings for the above-identified application. Kindly replace the informal drawings, as filed, with the enclosed drawings. No new matter has been added.

Please charge our Deposit Account No. **09-0458** for any fee relative to the acceptance of the attached formal drawings. A duplicate copy of this letter is enclosed for that purpose.

Respectfully submitted,

Peter W. Peterson

Reg. No. 31,867

**DeLIO & PETERSON, LLC**  
121 Whitney Avenue  
New Haven, CT 06510-1241

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